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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re **PATENT** application of:

Applicant: Benveniste et al.

Application No.: 10/606,087

Filing Date: June 25, 2003

Title: HIGH MASS RESOLUTION MAGNET FOR RIBBON BEAM ION  
IMPLANTERS

**PRELIMINARY AMENDMENT**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as indicated below.

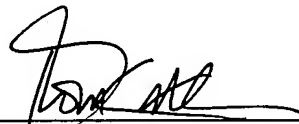
**In the Specification:**

Page 1, after the title, insert the following paragraph:

**--Related Application**

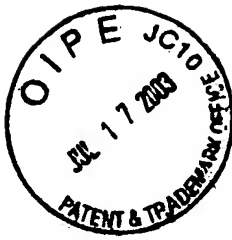
This application claims priority to U.S. Application No. 60/470,926 filed May 15, 2003, which is entitled "High Mass Resolution Magnet for Ribbon Beam Ion Implanters".

Respectfully submitted,  
ESCHWEILER & ASSOCIATES, LLC



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CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper or item referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first-class mail in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: July 14, 2003

Christine Gillroy  
Christine Gillroy